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 Applicant: Farrell et al.  
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## U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class/ Subclass

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## FOREIGN PATENT DOCUMENTS

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## OTHER DOCUMENTS

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"E.T. 1000 Wafer Transfer System", "E.T. 2000 Wafer Transfer System", and "Ergonomic Wafer Transfer System", MGI Electronics, Tempe, Arizona.

Examiner

*CMM/JF*

Date Considered

*9-26-03*